



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

August 7, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG822610094

LABORATORY GROWN DIAMOND

OVAL BRILLIANT

13.09 x 8.74 x 5.37 mm

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

EXCELLENT

D

INTERNALLY FLAWLESS

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

EXCELLENT

EXCELLENT

NONE

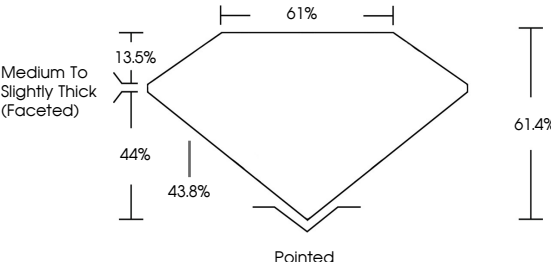
 LG822610094

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

LG822610094

Report verification at [igi.org](https://www.igi.org)

PROPORTIONS



Medium To Slightly Thick (Faceted)



Sample Image Used

LIGHT PERFORMANCE REPORT

Light Performance Grade: Exceptional



Structured Light Environment Representation

ModerateHighSuperiorExceptional

Light Performance

Brightness

Fire

Contrast

COLOR

D E F G H I J FaintVery LightLight

CLARITY

FL IF VS¹⁻² VS¹⁻² SI¹⁻² I¹⁻³

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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LABORATORY GROWN DIAMOND

OVAL BRILLIANT

13.09 X 8.74 X 5.37 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

3.87 CARATS

D

INTERNALLY FLAWLESS

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

EXCELLENT

EXCELLENT

NONE

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IGI

August 7, 2026

IGI Report No LG822610094

OVAL BRILLIANT

13.09 X 8.74 X 5.37 MM

Carat Weight

Color Grade

Depth

Table

Girdle

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

3.87 CARATS

D

IF

61.4%

61%

Medium To Slightly Thick (Faceted)

Pointed

EXCELLENT

EXCELLENT

NONE

 LG822610094

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